

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	10/576413	USPAT	OR	ON	2008/03/02 21:48
L2	1	10/576413	US-PGPUB; USPAT	OR	ON	2008/03/02 21:48
L3	20	Hatanaka near Yoshinori	US-PGPUB; USPAT	OR	ON	2008/03/02 21:49
L4	2	3 and (pixel near3 electrode)	US-PGPUB; USPAT	OR	ON	2008/03/02 21:49
L5	35243	semiconduct\$4 near2 (sensor or detector)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 21:51
L6	1745	(semiconduct\$4 near2 (sensor or detector)) same ((detect\$4 or measur\$4 or determin\$4) with ((x near ray) or gamma))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 21:52
L7	27	6 and ((wiring or wires) with (capacitance or parasitic))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 21:55
L8	24	7 and ((electrode or pixel) with (configur\$4 or arranged or disposed or placed))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 21:56
L9	2	7 and ((electrode or pixel) with (configur\$4 or arranged or disposed or placed) with (stagger\$3 or alternat\$4 or uneven or \$4uniform))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 21:56
L10	3	6 and ((cancel\$4 or compensat\$4 or uniform) near2 capacitance)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:02

L11	9	6 and ((wiring or wires) near2 capacitance)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:02
L12	4	(nagai near toshiko).in.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:10
L13	1	6 and (dummy near (section or wir\$4))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:12
L14	92	((semiconduct\$4 or radiation) near2 (sensor or detect\$4)) and (dummy near2 (wir\$4 or section or area))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:13
L15	5	((semiconduct\$4 or radiation) near2 (sensor or detect\$4)) and ((dummy near2 (wir\$4 or section or area)) same capacitance)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:13
L16	41	((semiconduct\$4 or radiation) near2 (sensor or detect\$4)) and (capacitance with "same" with wir\$4)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:16
L17	68	((semiconduct\$4 or radiation) near2 (sensor or detect\$4)) and (capacitance with (uniform or equal or "same") with wir\$4)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:16
L18	19	17 and (electrode with amplif\$7)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:17

L19	19	((semiconduct\$4 or radiation) near2 (sensor or detect\$4)) and (capacitance with (uniform or equal or "same") with wir\$4) and ((pixel or sensor) with (shift\$4 or stagger\$4))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:19
L20	10	17 and ((electrode or pixel) with (configur\$4 or arranged or disposed or placed) with (stagger\$3 or alternat\$4 or uneven or \$4uniform))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:20
L21	9	17 and ((sensor or pixel) with (configur\$4 or arranged or disposed or placed) with (stagger\$3 or alternat\$4 or uneven or \$4uniform))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:20
L22	28	17 and ((sensor or pixel) near3 (configur\$4 or arranged or disposed or placed))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:21
L23	19	22 not 21	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:22
L24	19	23 not 20	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:22
L25	3	24 and ((x near ray) or gamma)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:23
L26	731	(wiring near pattern) with capacitance	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:29

L27	2	17 and 26	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:29
L28	0	("2007/0057190").URPN.	USPAT	OR	ON	2008/03/02 22:31
L29	109400	((sensor or pixel) with (stagger\$3 or alternat\$4 or shifted))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:32
L30	48553	((sensor or pixel) near3 (stagger\$3 or alternat\$4 or shifted))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:32
L31	45	6 and 30	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:33
L32	11648	((sensor or pixel) near3 (stagger\$3 or shifted))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:33
L33	45	6 and 31	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:34
L34	8	6 and 32	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:34
L35	1061	(wiring or wire) with capacitance with width	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:38

L36	127	(wiring or wire) with capacitance with width with ("same" or compensate or equal or uniform)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:39
L37	3	6 and 36	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:39
L38	5	((semiconduct\$4 or radiation) near2 (sensor or detect\$4)) and 36	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:40
L39	2	38 not 37	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:40
L40	1304	250/370.09.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:42
L41	27371	capacitance near3 ("same" or compensate or equal or uniform)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:42
L42	43	40 and 41	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:42
L43	2306	(capacitance near3 ("same" or compensate or equal or uniform)) same (pixel or sensor)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:43

L44	16	40 and 43	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:43
L45	314	250/370.14.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:45
L46	3	45 and 43	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:45
L47	1561	((semiconduct\$4 or radiation) near2 (sensor or detector)) same ((detect \$4 or measur\$4 or determin\$4) with ((x near ray) or gamma)).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:46
L48	0	47 and (capacitance near3 (equal or "same" or uniform or compensate)). clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:47
L49	0	47 and (capacitance with (equal or "same" or uniform or compensate)). clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:47
L50	5590	(capacitance with (equal or "same" or uniform or compensate)).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:47
L51	13	50 and ((radiation or semiconduct\$4 or (x near ray) or gamma) near (sensor or detector)).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/02 22:48

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